

<b>Notice of References Cited</b>	Application/Control No. 09/893,994	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Jennifer T Nguyen	Art Unit 2674	Page 1 of 1

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U	Park et al. Pub. No.: US 2002/0084964	July 4, 2002
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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